

**FEE TRANSMITTAL**

Electronic Version v08

Stylesheet Version v08.0

**Title of  
Invention**

METHOD OF FORMING A POLYSILICON RESISTOR

Application Number :

Date :

First Named Applicant: Cheng-Hsiung Chen

Attorney Docket Number: NAUP0525USA

**TOTAL FEE AUTHORIZED \$ 810**

Patent fees are subject to annual revisions on or about October 1st of each year.

Filing as large entity

**BASIC FILING FEE**

Fee Description	Fee Code	Amount \$	Fee Paid \$
Utility Filing Fee	1001	770	770
Subtotal For Basic Filing Fees: \$ 770			

**EXTRA CLAIM FEES**

Fee Description	Extra Claim	Fee Code	Amount \$	Fee Paid \$
Total Claims : 13	0	1202	18	0
Independent Claims : 2	0	1201	86	0
Subtotal For Extra Claims Fees: \$ 0				

**ASSIGNMENT FEES**

Fee Description	Property Number	Quantity	Fee Code	Amount \$	Fee Paid \$
Recording Each Patent Assignment Per Property Fee	00000000	1	8021	40	40
Subtotal For Additional Fees: \$40					

**AUTHORIZED BILLING INFORMATION**

**The commissioner is hereby authorized to charge indicated fees and credit any overpayments to:**

Deposit account number: 503105

Access Code \*\*\*\*

Deposit name: North America Intellectual Property Corporation

Deposit authorized name: /WINSTON HSU/

Signature: /VAEB-JMXX-8IIL/

Date (YYYYMMDD):

2004-09-13

Charge Assignment Fees Required Under 37 C.F.R. Section 1.21 (h).

Charge Any Additional Fee Required Under 37 C.F.R. Sections 1.16 and 1.17.